



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of	:	Customer Number: 20277
Akihiko ISHIBASHI, et al.	:	Confirmation Number: 6705
Serial No.: 09/692,211	:	Group Art Unit: 2812
Filed: October 20, 2000	:	Examiner: Savitri MULPURI
For: METHOD OF FABRICATING NITRIDE SEMICONDUCTOR DEVICE	:	

**RESPONSE UNDER 37 C.F.R. § 1.111**

Mail Stop Non-Fee Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

In response to the Office Action dated April 7, 2003, having a shortened statutory period for response set to expire July 7, 2003, a petition for a two month extension of time up to and including September 7, 2003 being filed concurrently herewith, Applicants respectfully request reconsideration of the pending rejection for the reasons set forth below.

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TECHNICAL SERVICES DIVISION